



03500.013974

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
TADAHIRO OHMI ET AL.  
Application No.: 09/425,015  
Filed: October 25, 1999  
For: GAS SUPPLY PATH  
STRUCTURE FOR A GAS LASER

Examiner: Davienne Monbleau  
Group Art Unit: 2874

November 18, 2002

Commissioner for Patents  
Washington, D.C. 20231

PETITION UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the final Office Action dated July 16, 2002 for one (1) month from October 16, 2002 to November 16, 2002 (Saturday).

Submitted herewith is a check for \$110.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205.

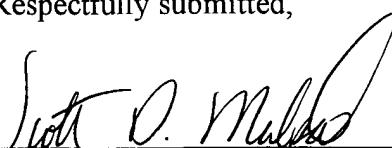
Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 230-1010. All correspondence should continue to be directed to our address given below.

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Respectfully submitted,

  
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Attorney for Applicants

Registration No. 32,533

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